



85578RLO
Customer No. 01333

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Jeremy M. Grace, et al

THERMAL PHYSICAL VAPOR
DEPOSITION SOURCE WITH
MINIMIZED INTERNAL
CONDENSATION EFFECTS

Serial No. US 10/786,859

Filed 25 February 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA. 22313-1450

Sir:

Group Art Unit: 2818
Confirmation No. 3654
Examiner: Thao P. Le

I hereby certify that this correspondence is being
deposited today with the United States Postal
Service as first class mail in an envelope addressed
to Commissioner For Patents, P.O. Box 1450,
Alexandria, VA 22313-1450.

Joyce Delrie

Date

12.8.04

Amendment

In response to the Office Action mailed October 4, 2004, please
reconsider the rejection of the above-identified application, without prejudice, in
view of the following remarks.

Amendments to the Drawings begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.